

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KOBAYASHI  
Application No.: 10/563,302  
Filed: 1/4/2006  
Title: ELECTROSTATIC CHUCK FOR SUBSTRATE STAGE, ELECTRODE USED  
FOR THE CHUCK, AND TREATING SYSTEM HAVING THE CHUCK AND  
ELECTRODE  
Art Unit: 2836 Exr.: T. MAI CONF. No.: 8395

**SUPPLEMENTAL AMENDMENT**  
**and**  
**STATEMENT OF SUBSTANCE OF INTERVIEW**

**MS: AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**November 8, 2010**

Sir:

In supplement to the Amendment filed on September 23, 2010, and in accordance with telephone interviews conducted with Exr. Mai on October 20, 2010, November 1, 2010 and November 5, 2010, please amend the above-identified application as listed below and as set forth on the following pages:

**Amendments to the Claims;**

**Remarks are included following the amendments.**